

•	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/646,856	TAMARESELVY ET AL.
	Examiner	Art Unit
	Lakshmi S. Channavajjala	1615

Subclass		
	Date	Examiner
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		-

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
	DATE	EXMR			
consulted David Wu SPE 1713, because polymer examined in 1713. Mr. Wu suggesteda second restrcition	3/14/2007	LC			
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